



Attorney Docket: 622/48561
PATENT

#25
12/18/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: MARTIN DUBS ET AL.
Serial No.: 09/484,421 Group Art Unit: 1753
Filed: JANUARY 18, 2000 Examiner: G. CANTELMO
Title: SPUTTER CHAMBER AS WELL AS VACUUM TRANSPORT
CHAMBER AND VACUUM HANDLING APPARATUS WITH
SUCH CHAMBERS

LETTER REQUESTING DRAWING CHANGE APPROVAL

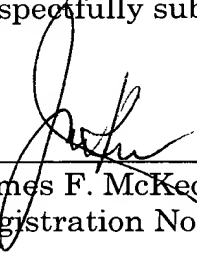
Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants propose to amend Figs. 2a and 2b in accordance with the attached re-line print. It is understood that the record is clear that the radius $\phi/2$ can include embodiments which were shown by the outer dash lines (now deleted).

Respectfully submitted,

December 18, 2002


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